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APPLICATION INFORMATION

Title Line One:: A METHOD OF MANUFACTURING A SUBSTRATE WITH CO Title Line Three:: NCAVE PORTIONS, A SUBSTRATE WITH CO Title Line Four:: PORTIONS FOR MICROLENSES, A MICROLENS S Title Line Five:: UBSTRATE, A TRANSMISSION SCREEN AND A RE

Title Line Six:: AR PROJECTOR

Total Drawing Sheets:: 17
Formal Drawings?:: Yes
Application Type:: Utility
Docket Number:: 9319A-000658

Secrecy Order in Parent Appl.?:: No

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2003-019589

Filing Date:: 01-28-2003

Country:: Japan

1,00

Priority Claimed:: Yes
Foreign Application Two:: 2003-144083
Filing Date:: 05-21-2003

Country:: Japan

Priority Claimed:: Yes

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